

## MEMS Die Holder

### ABSTRACT OF THE DISCLOSURE

5           A method and article are provided for batch processing of a plurality of  
MEMS dice. The MEMS dice are secured in a holder having multiple stations adapted to  
secure a MEMS die. A process step is then performed on the plurality of MEMS dice while  
they are secured in the holder and may be performed simultaneously on all of the MEMS dice  
secured in the holder.

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